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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT APPLICATION of

Shuichi Noda

Group Art Unit: 1765

Serial No.: 10/084,192 ✓

Examiner: Deo, Euy Vu Nguyen

Filed: February 28, 2002

Confirmation No. 4931

METHOD FOR ETCHING AN  
ANTIREFLECTIVE COATING AND FOR  
FABRICATING A SEMICONDUCTOR  
DEVICE

**REQUEST FOR ACKNOWLEDGMENT OF RECEIPT OF  
CERTIFIED COPY OF PRIORITY DOCUMENT**

**Mail Stop ISSUE FEE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

On February 28, 2002, a Claim of Priority was filed in the subject application, copy attached. As of the present date, however, acknowledgment of receipt of the priority document has not been made.

Please check the file of the above-identified application and confirm that the priority document has been received.

Respectfully submitted,

VOLENTINE FRANCOS, PLLC

Adam C. Volentine  
Registration No. 33,289

12200 Sunrise Valley Drive, Suite 150  
Reston, Virginia 20191  
Telephone No.: (703) 715-0870  
Facsimile No.: (703) 715-0877

Dated: May 19, 2004

**COPY**



**REQUEST FOR EARLY NOTIFICATION OF SERIAL NUMBER**

**ATTY DOCKET #:** OKI.310

**DUE DATE:** August 10, 2002

**APPLICANT:** Shuichi NODA

**SERIAL NO.:** (NEW)

**FEB 28 2002**

**FILING DATE:** February 28, 2002

**TITLE:** METHOD FOR ETCHING AN ANTIREFLECTIVE COATING AND FOR FABRICATING A SEMICONDUCTOR DEVICE

**RECEIPT OF THE FOLLOWING PAPERS IS ACKNOWLEDGED:**

New U.S. Patent Application including: Utility Patent Application Transmittal; Recordation Form Cover Sheet including Assignment (2 pages); specification, claims and abstract (21 pages); Declaration and Power of Attorney (3 pages); 5 sheets of drawings for Figures 1-6e; Claim of Priority including 1 priority document; Transmittal of Information Disclosure Statement, PTO-1449 Form and 1 reference; and \$780 filing fee.

**DATE:** February 28, 2002

**ATTY:** ACV

**[Check No. 9523]**



**COPY**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of :

Shuichi NODA :

Serial No.: [NEW] :

Attn: Applications Branch

Filed: February 28, 2002 :

Attorney Docket No.: OKI.310

For: METHOD FOR ETCHING AN ANTIREFLECTIVE COATING AND FOR  
FABRICATING A SEMICONDUCTOR DEVICE

**CLAIM OF PRIORITY**

Honorable Assistant Commissioner for Patents and Trademarks,  
Washington, D.C. 20231

Sir:

Applicant, in the above-identified application, hereby claims the priority date  
under the International Convention of the following Japanese application:

Appln. No. 2001-243275 filed August 10, 2001

as acknowledged in the Declaration of the subject application.

A certified copy of said application is being submitted herewith.

Respectfully submitted,

VOLENTINE FRANCOS, PLLC

  
Adam C. Volentine  
Registration No. 33,289

12200 Sunrise Valley Drive, Suite 150  
Reston, Virginia 20191  
Tel. (703) 715-0870  
Fax. (703) 715-0877

Date: February 28, 2002

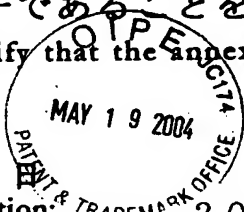


本 国 特 許 庁  
JAPAN PATENT OFFICE

COPY

別紙添付の書類に記載されている事項は下記の出願書類に記載されて  
いる事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed  
with this Office



出 願 年 月 日  
Date of Application: 2001年 8月10日

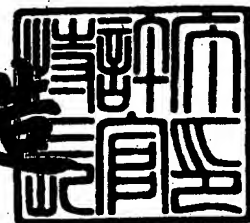
出 願 番 号  
Application Number: 特願2001-243275

出 願 人  
Applicant(s): 沖電気工業株式会社

2001年10月26日

特 許 庁 長 官  
Commissioner,  
Japan Patent Office

及 川 耕 造



出証番号 出証特2001-3094371